Docket No.: APPM/008244US/DSM/BCVD/JW 1016.014014 (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: § Ling Chen, et al. Group Art Unit: 2893 Serial No.: 10/799.146 Confirmation No.: 7933 Examiner: M. D. Harrison Filed: March 12, 2004 METHOD OF DEPOSITING AN For: AMORPHOUS CARBON FILM

APPLICATION MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450

FOR FTCH HARDMASK

Alexandria, VA 22313-1450

Dear Sir

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted via the Office electronic filing system in accourdance with § 1.6(a)(4). (Keith M. Tackett)

STATEMENT OF COMMON OWNERSHIP

The present application Serial No. 10/799.146 (hereinafter the "Application") and U.S. Patent No. 6.853.043 to Yeh, et al. were, at the time the invention of the Application was made, owned by, or subject to an obligation of assignment to, Applied Materials, Inc., of Santa Clara, California.

Respectfully submitted.

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